

<b>Notice of References Cited</b>	Application/Control No. 10/849,192		Applicant(s)/Patent Under Reexamination TAKEUCHI ET AL.	
	Examiner Ryan Lepisto		Art Unit 2883	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0089996	07-2002	Komatsu et al.	370/442
*	B	US-5,983,294	11-1999	Kim et al.	710/62
*	C	US-2004/0109408	06-2004	Mesh et al.	370/222
*	D	US-6,804,248	10-2004	Tomar et al.	370/401
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.